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Patent  
Attorney Docket 4439

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Nobuhiro Hayashi, Takayoshi Hirono )  
Isao Tada, Atsushi Nakatsuka )

Application No.: 10/574,715 )

Filed: March 27, 2006 )

For: Vacuum Evaporation Deposition Method )  
of the Winding Type and Vacuum )  
Evaporation Deposition Apparatus of the )  
Same )

Smith, Francis P.  
Patent Examiner  
Art Unit 1792

Pittsburgh, Pennsylvania

**AMENDMENT AND PETITION FOR THREE MONTH  
EXTENSION OF TIME UNDER 37 CFR 1.136(a)**

Mail Stop Patent Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This Amendment is filed in response to the Non-Final Office Action dated April 20, 2009 and a request for a three month extension for response to the Office Action is enclosed requesting a three month extension whereby response to the Office Action will now be due on or before October 20, 2009. The required extension fee for a large entity is enclosed in the amount of \$1,110.00 in the form of a check made payable to the Director of Patents and Trademarks. Kindly accept the requested extension and consider the following amendments to the claims and remarks.